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10/564,452	01/12/2006	Christina Ammann	3717519.00038	8957
29157 7590 11/26/2010 K&L Gates LLP		EXAMINER		
P.O. Box 1135			GWARTNEY, ELIZABETH A	
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K&L GATES LLP P.O. BOX 1135 CHICAGO, IL 60690 Application: 2011-002138 Application: 10/564,452

Appellant: Christina Ammann et al.

Board of Patent Appeals and Interferences Docketing Notice

Application 10/564,452 was received from the Technology Center at the Board on November 15, 2010 and has been assigned Appeal No: 2011-002138.

In all future communications regarding this appeal, please include both the application number and the appeal number.

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